

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/560,051	OKABE ET AL.	
Examiner	Art Unit	
Son T. Nauven	3643	

	CEARCHER				
	SEARCHED				
Class	Subclass	Date	Examiner		
		-			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
		71		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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